

Mid-IR AlGa_{0.3}N quantum cascade detector on silicon

Device promising for integrated-optoelectronics technology, showing potential for ultra-fast operation at very wide spectral range

Technion-Israel Institute of Technology claims the first demonstration of an aluminium gallium nitride (AlGa_{0.3}N) quantum cascade detector (QCD) grown on 4-inch-diameter silicon substrates [Ben Dror et al, IEEE Electron Device Letters, published online 7 December 2018]. The detection wavelength was in the mid-infrared range (3–8 μm). The long wavelength was enabled by inter-sub-band transitions (ISBTs) in the quantum cascade structure.

The team comments: "The successful implementation of [a] GaN ISBT optoelectronic device on silicon is promising [for] integrated-optoelectronics technology, showing great potential for ultra-fast operation at a very wide spectral range."

The QCD (Figure 1) was based on a 30-period cascade structure with an inter-sub-band transition energy of 267 meV, corresponding to 4.49 μm wavelength. The electron flow between stages was facilitated by longitudinal optical (LO) phonon-assisted tunneling. Infrared excitation of the structure produced a photovoltage.

The AlN/Si (111) 4"-diameter templates for the QCD structure were prepared by metal-organic chemical vapor deposition (MOCVD). The device layers were added by plasma-assisted molecular beam epitaxy (PAMBE) at 720 °C.

Devices were fabricated on 7 mm x 7 mm pieces diced from the epitaxial wafer. Mesas measuring 700 μm x 700 μm were etched by inductively coupled plasma. The metal contacts consisted of titanium/aluminium (Ti/Al). The center of the top of the mesa was kept clear of contact metal as a window for front illumination into the absorbing layer.

The determination of the peak detection wavelength was hampered by the nearby presence of carbon dioxide absorption at 4.3 μm (Figure 2). The researchers

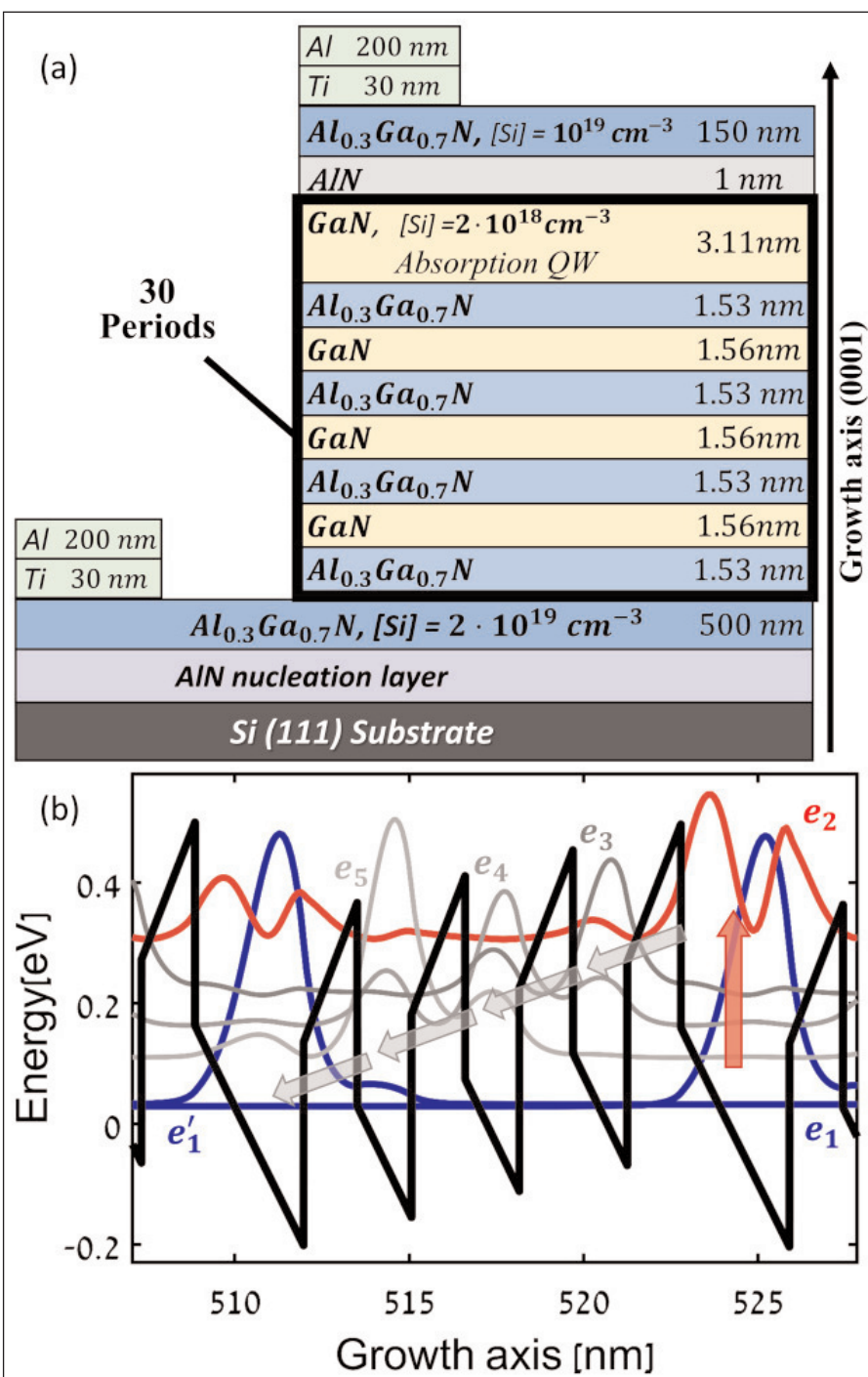


Figure 1. (a) Schematic of QCD structure. (b) Calculated conduction-band profile of 1.5 period of QCD's active area and shifted squared envelope functions of electronic bound states. Red vertical arrow indicates optical transition; gray arrows indicate transport direction of electrons in extractor region.

extracted a peak value of $4.14\mu\text{m}$ at 18K, red-shifting to $4.5\mu\text{m}$ at 150K. The 18K detection linewidth was $1.26\mu\text{m}$ full-width at half maximum (FWHM). The peak response also declines with increasing temperature, apparently disappearing into noise above 150K.

Absolute responsivity was measured using a 1000K silicon carbide globular blackbody source. At 18K, a measured photocurrent of 162pA corresponded to a $44\mu\text{A/W}$ response. The detectivity, which incorporates the responsivity, the area of the blackbody aperture, and the current noise spectral density ($15.4\text{fA/Hz}^{1/2}$), was 2×10^8 Jones at 19K.

The researchers suggest a number of potential improvements: optimizing the trade-off between absorption, extraction efficiency and resistance; reducing unwanted diagonal transitions from the ground state to the extractor quantum wells, increasing resistance and decreasing dark current; enhancing electron transport by tailoring the energy levels in the extraction stage to the LO-phonon ladder;

and, increasing the doping to boost electron density in the quantum well for greater absorption. ■

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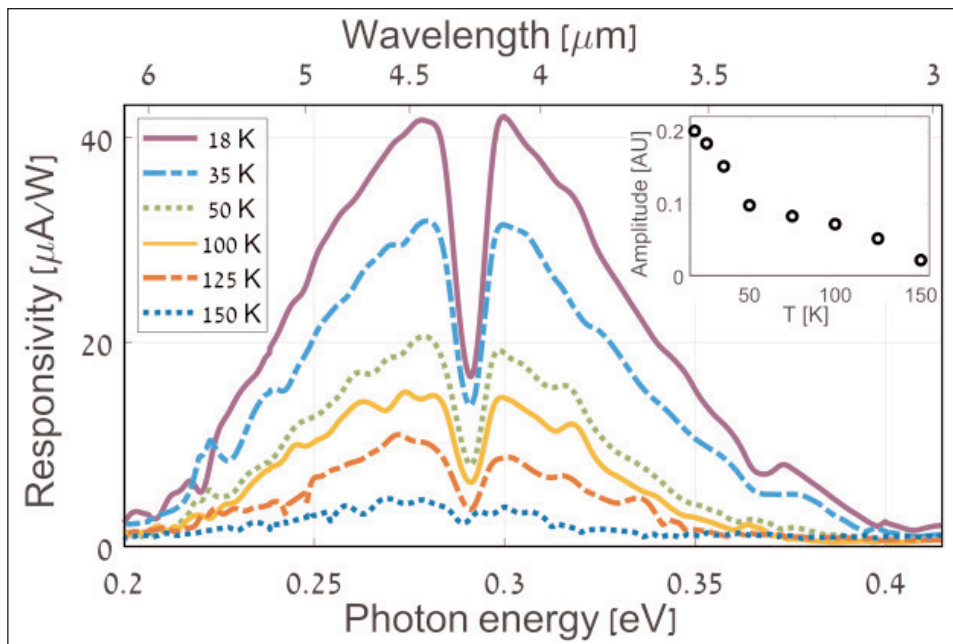


Figure 2. Spectral response of device. Dip is due to CO_2 absorption. Inset: temperature dependence of signal is shown – peak signal at 18K.

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